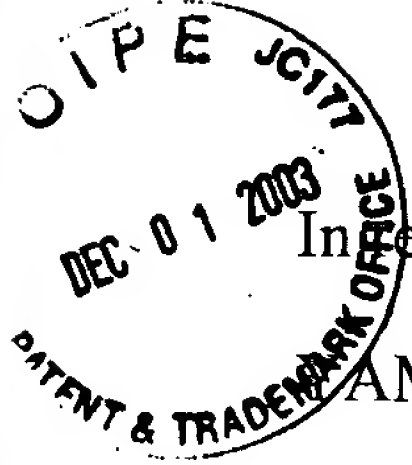


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



In re Patent Application of

AMAGATA et al.

Atty. Ref.: 925-219; Confirmation No. 7689

Appl. No. 09/993,890

Group: 2825

Filed: November 27, 2001

Examiner: Lee, Calvin

For: METHOD FOR MANUFACTURING NONVOLATILE SEMICONDUCTOR  
MEMORY WITH NARROW VARIATION IN THRESHOLD VOLTAGES OF  
MEMORY CELLS

\* \* \* \* \*

December 1, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE AFTER FINAL**

Responsive to the Official Action dated August 26, 2003 (for which petition is  
hereby made for a one month extension of time), reconsideration is respectfully requested  
for at least the following reasons.

RECEIVED  
DEC - 5 2003  
TECHNOLOGY CENTER 2800

12/02/2003 TLWJ11 00000021 09993890

01 FC:1251

110.00 OP